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	T pyr pyr	S.D.ATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
APPLICATION NO.	FILING DATE			004678 1104	1740
09/844,171	04/25/2001		Thomas R. Schimert	004578.1104	. 1740
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Jerry W. Mill			EXAMINER		
Baker Botts L.			MORAN, TIMOTHY J		
Suite 60 2001 Ross Avenue				ART UNIT	PAPER NUMBER
Dallas, TX 75	5201-2980			2878	

DATE MAILED: 04/24/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

1 0				(x)			
,		Application No.	Applicant(s)	- M			
	_	09/844,171	SCHIMERT ET AL.				
	Office Action Summary	Examiner	Art Unit				
		Timothy J. Moran	2878				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
THE I - External after - If the - If NC - Failu - Any r	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. nsions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. It period for reply specified above is less than thirty (30) days, a reply operiod for reply is specified above, the maximum statutory period or reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may within the statutory minimum of the will apply and will expire SIX (6) Mode, cause the application to become	a reply be timely filed nirty (30) days will be considered timely. DNTHS from the mailing date of this com ABANDONED (35 U.S.C. § 133).	munication.			
1)	Responsive to communication(s) filed on 24 F	February 2003 .					
2a)□	•	is action is non-final.					
3)	Since this application is in condition for allowa- closed in accordance with the practice under	ance except for formal m		merits is			
Dispositi	ion of Claims	Expanto quayro, ross c	7.5. 71, 100 0.0.210.				
4)⊠	Claim(s) <u>1-9,12,13,16,18 and 28-37</u> is/are per	nding in the application.					
	4a) Of the above claim(s) is/are withdraw	wn from consideration.					
5)[🗆	Claim(s) <u>1,16,18 and 32-37</u> is/are allowed.						
6)⊠	Claim(s) <u>2-9,12,13 and 28-31</u> is/are rejected.						
7)	Claim(s) is/are objected to.						
	Claim(s) are subject to restriction and/o	r election requirement.					
• •	ion Papers						
<i>,</i> —	The specification is objected to by the Examine		the Europian				
10)[_]	The drawing(s) filed on is/are: a) accept						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.							
If approved, corrected drawings are required in reply to this Office action. 12) The oath or declaration is objected to by the Examiner.							
,	under 35 U.S.C. §§ 119 and 120						
•	Acknowledgment is made of a claim for foreign	n priority under 35 U.S.C	& 119(a)-(d) or (f)				
•	☐ All b)☐ Some * c)☐ None of:	repriemly under do ordin	. 3 (4) (4) (1)				
۵,	1. Certified copies of the priority document	s have been received.					
	2. Certified copies of the priority documents have been received in Application No						
* (Copies of the certified copies of the prio application from the International Buse the attached detailed Office action for a list	rity documents have bee reau (PCT Rule 17.2(a)	en received in this National S	tage			
	Acknowledgment is made of a claim for domesti	•		application).			
a) The translation of the foreign language provisional application has been received. 15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.							
Attachmer	•						
2) Notice	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s) <u>1</u>	5) Notice	w Summary (PTO-413) Paper No(s of Informal Patent Application (PTO				
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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on February 24, 2003 has been entered.

Withdrawal of Indicated Allowability

The indicated allowability of claims 2-9, 12-13, and 28-31 is withdrawn in view of the newly discovered reference(s) to Hornbeck. Rejections based on the newly cited reference(s) follow.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 12, 3, 6, 28, and 30 are rejected under 35 U.S.C. 102(b) as being anticipated by Hornbeck, U. S. Patent No. 5,021,663. Regarding claim 12, Hornbeck describes (fig. 4a) an infrared detector apparatus comprising an amorphous silicon portion (150), first and second electrodes (148), and a third electrode (152) on a side

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opposite from the first and second electrodes. Regarding the limitation "having a structural configuration which is selected to provide ... a resistance which is selected substantially independently of said temperature coefficient of resistance," it is understood that the resistance of the configuration of Hornbeck is selected substantially due to the resistance of the amorphous silicon portion and the dimensions of the amorphous silicon portion and the electrodes. Therefore the configuration is understood to be selected substantially independently of the temperature coefficient of resistance.

Regarding claim 3, Hornbeck teaches that the electrodes are in thermal communication with the amorphous silicon portion.

Regarding claim 6, Hornbeck teaches that the infrared detector includes an integrated circuit (fig. 2) and a membrane (fig. 4a).

Regarding claim 28, the methods described are inherently implied in the use of the apparatus of claim 12.

Regarding claim 30, the methods described are inherently implied in the use of the apparatus of claim 3.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of

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the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 2, 7, 13, 29, and 31 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hornbeck as applied to claim 12 above, and further in view of Villain, U. S. Patent No. 5,912,464. Regarding claim 2, Hornbeck does not teach the selection of doping levels to produce a selected temperature coefficient of resistance. However, such doping methods are well known in the art, including Villain (col. 8, lines 31-46). Therefore it would have been obvious to one of ordinary skill in the art to use such methods with the apparatus of Hornbeck for the advantage of optimizing detector performance.

Regarding claim 7, Hornbeck does not teach the use of a resonant cavity.

However, Villain teaches that the integrated circuit has thereon a reflective surface (fig. 8A and 8B, element 21, col. 14, line 63-col. 15, line 3), wherein a distance between said reflective surface and said membrane is selected to form a resonant cavity (col. 10, lines 19-30, col. 11, lines 8-10, and col. 13, lines 54-58). Therefore it would have been obvious to one of ordinary skill in the art to use such methods in the apparatus of Hornbeck to increase sensitivity.

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Regarding claim 13, Villain teaches (element 32, fig. 16, col. 16, lines 13-23) that first and second electrically insulating layers (silicon nitride) can be fabricated above (eleventh step) and below (adjacent to polyimide) the amorphous silicon layer and electrodes. Note that the limitation "substantially transparent to infrared radiation" is implied by the statement that the reflective surface below the membrane reflects a substantial amount of infrared radiation (col. 10, lines 19-30).

Regarding claim 29, the methods described are inherently implied in the use of the apparatus of claim 2.

Regarding claim 31, the methods described are inherently implied in the use of the apparatus of claim 7.

Claims 4-5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hornbeck as applied to claim 12 above, and further in view of Kimura, U. S. Patent No. 5,589,688. Regarding claim 4, Hornbeck does not teach that the electrodes are made from an alloy which includes aluminum and titanium. However, Kimura describes (fig. 2) an infrared radiation sensor with a thermally sensitive silicon portion (element 1) and electrodes (5) made from an alloy of aluminum and titanium (col. 6, lines 5-6 and col. 9, lines 44-48). Therefore it would have been obvious to one of ordinary skill in the art to provide for electrodes made from such an alloy in the apparatus of Hornbeck for the benefit of electrical connection to the thermally sensitive portion.

Regarding claim 5, Kimura does not specify a composition range for the aluminum-titanium alloy. However, since both are well known to be good conductors, it is considered reasonable to use an alloy which includes approximately equal amounts

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of aluminum and titanium. Therefore it would have been obvious to one of ordinary skill in the art to use such an alloy in the modified apparatus of Villain for the benefit of electrical connection to the thermally sensitive portion.

Claims 8-9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hornbeck and Villain as applied to claim 7 above, and further in view of Agnese, U. S. Patent No. 5,825,029. Regarding claim 8, Hornbeck does not teach that the membrane has a plurality of openings. However, Agnese describes (fig. 3 and fig. 4) a infrared sensing apparatus comprising a membrane (12) comprising a thermally sensitive portion (16) in contact with electrodes (22 and 24, col. 3, lines 17-30), where the membrane has a plurality of openings for the advantage of better absorbing infrared radiation. Therefore it would have been obvious to one of ordinary skill in the art to provide for a plurality of openings in the membrane of Villain for the advantage of better absorbing infrared radiation.

Regarding claim 9, Agnese teaches that the spacing of the grid openings have a length equivalent to half the wavelength of interest (col. 5, lines 5-8), and that the distance between the membrane and the cavity bottom should be equal to one quarter of the wavelength of interest (col. 4, lines 3-7). Therefore it would have been obvious to provide for openings with a transverse dimension approximately twice the distance between the reflective surface and the membrane in the modified apparatus of Villain for the advantage of better absorbing infrared radiation.

Allowable Subject Matter

Claims 1, 16, 18, and 32-37 are allowed.

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The following is a statement of reasons for the indication of allowable subject matter: Claims 1 and 16 include limitations that the infrared detector apparatus comprises two electrodes electrically coupled to an amorphous silicon portion which are disposed on two insulating portions.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Timothy J. Moran whose telephone number is 703-305-0849. The examiner can normally be reached on M-F 8:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Porta can be reached on 703-308-4852. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7724 for regular communications and 703-308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

T.M.

April 22, 2003

PRIMARY EXAMINER

GROUP ART UNIT 2878